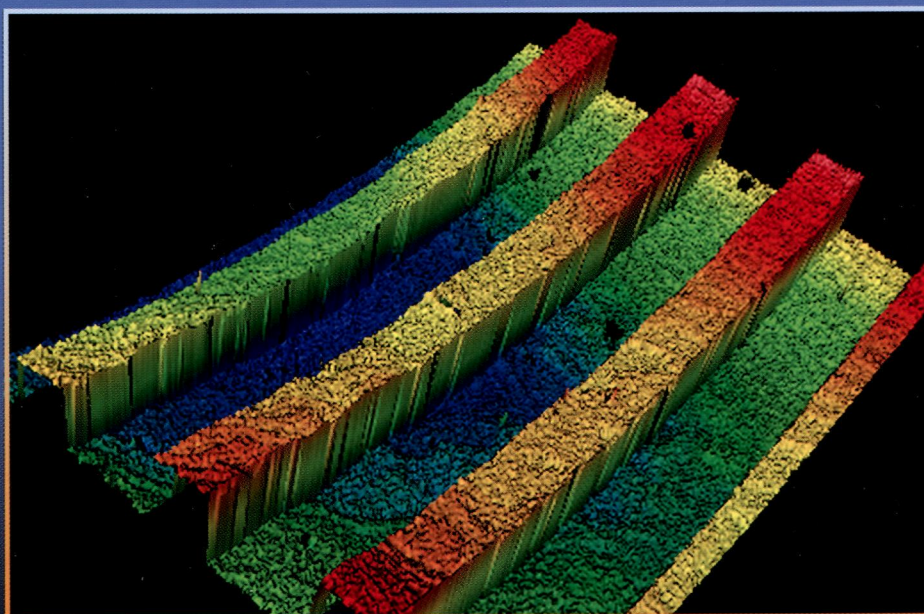


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# JVSTA

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## Vacuum, Surfaces, & Films



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**On The Cover:** *Peter J. Cumpson, Jose F. Portoles, and Naoko Sano, JVST A, 31(2), p. 020605-3 (2013). Cover shows a topography map of a sputter crater in polystyrene formed by argon ion clusters. Argon cluster-ion sources are leading to major benefits in the surface analysis of organic materials.*